

Japan TC Chapter of Automation Technology Global Technical Committee Meeting Summary and Minutes

Japan Standards Winter 2016 Meetings
Tuesday, January 19, 2016, 1:30 p.m. – 3:30 p.m.
SEMI Japan office, Tokyo, Japan

Next Committee Meeting

13:30-15:30 April 22, 2016 <Japan Standard Time>
SEMI Japan, Tokyo, Japan

Committee Announcements (optional)

None

Table 1 Meeting Attendees

Italics indicates virtual participants

Co-Chairs: Makoto Ishikawa (Nisshinbo Mechatronics), Teruaki Ito (Mitsubishi Electric), Terry Asakawa (Tokyo Electron)

SEMI Staff: Junko Collins (SEMI Japan)

Attendee: 4 + **SEMI:** 1

| <i>Company</i> | <i>Last</i> | <i>First</i> | <i>Company</i> | <i>Last</i> | <i>First</i> |
|---------------------|-------------|--------------|---------------------|-------------|--------------|
| Mitsubishi Electric | Yutani | Takashi | Tokyo Electron | Murata | Naoko |
| Tokyo Electron | Asakawa | Terry | Mitsubishi Electric | Yagi | Takahiro |
| | | | SEMI Japan | Collins | Junko |

Table 2 Leadership Changes

None

Table 3 Ballot Results (or move to Section 5, Ballot Review)

None

Table 4 Authorized Ballots (or move to Section 8, New Business)

None

Table 5 Authorized Activities (or move to Section 8, New Business)

None

Table 6 New Action Items (or move to Section 9, Action Item Review)

| <i>Item #</i> | <i>Assigned to</i> | <i>Details</i> |
|---------------|--------------------|-----------------------------------------------------------------------------------------------------------------------------------------------------------------------|
| 2016-0119-01 | Staff | With respect for changing designation letter, official statement was not received by the TC Chapter yet. Staff should gain the written statement for this TC Chapter. |
| 2016-0119-02 | EIS TF | To submit the SNARF for revision to PV35.1 to remove limitation data block length to the TC Chapter before the next TC Chapter Meeting. |

Table 7 Open Actions Items (or move to Section 9, Action item Review)

| <i>Item #</i> | <i>Assigned to</i> | <i>Details</i> |
|---------------|--------------------|----------------|
| | | None |

1 Welcome, Reminders, and Introductions

Terry Asakawa (Tokyo Electron), co-chair, called the meeting to order at 1:30 p.m. The meeting reminders on antitrust issues, intellectual property issues and holding meetings with international attendance were reviewed by SEMI Staff. Attendees introduced themselves.

Attachment: Required_Elements_Reg_20150327_E+J

2 Review of Previous Meeting Minutes

The committee reviewed the minutes of the previous meeting.

| | |
|-----------------------------|----------------------------------------------------------------|
| Motion: | To approve the previous meeting minutes written as it is. |
| By / 2nd: | Naoko Murata (Tokyo Electron) / Terry Asakawa (Tokyo Electron) |
| Discussion: | None |
| Vote: | 3 in favor and 0 opposed. Motion Passed. |

3 Liaison Reports

3.1 Europe TC Chapter

All participants reviewed the attached report.

Attachment: Automation Technology EU Jan 2016

3.2 FlowMaster Forum

During SEMICON Japan 2016, SEMI FlowMaster Forum exhibited the Z-gauge railway model using PLC of which SEMI PV35 is implemented, in the area of Sustainable Manufacturing Pavilion.

4 SEMI Staff Report

Junko Collins (SEMI Japan) gave the SEMI Staff Report as attached materials. Of note:

- Global SEMI Events
- Global Standards Meetings Schedule
- Ballot Critical Dates
- New Regulations and Procedure guide
- Contact Information

Attachment: SEMI Staff Report 20151215_r1(AT)

5 Ballot Review

None

6 Subcommittee & Task Force Reports

6.1 Equipment Interface Specification (EIS) Task Force

No special report from the task force.

However, participants confirmed that this task force has to move forward the activity for removing limitation data block length from PV35.1, and agreed the task force should submit the SNARF for revision activity regarding PV35.1 to the TC Chapter before the next TC Chapter Meeting.

7 Old Business

Changing Designation Letter

See Action Item 2016-0119-01

8 New Business

No new business

9 Action Item Review

9.1 Open Action Items

Junko Collins (SEMI Japan) reviewed the open action item. This can be found in the Open Action Items table at the beginning of these minutes.

| <i>Item #</i> | <i>Assigned to</i> | <i>Details</i> |
|---------------|--------------------|-------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------------|
| 20150930-1 | TC Chapter Chairs | To send the TC Chapter statement to Regulation SC Chair and responsible HQ staff (cc to ISC chairs, Reg. SC members, AT Global TC Chairs) Contents of Statement <ul style="list-style-type: none"> - Designation letter managed and/or developed by AT must be AT - PV2, PV35, PV35.1 should be changed immediately - This will be effective at the SEMICON Japan and the necessary procedure will retroactively be done. Done, but See new Action Item 2016-0119-01 |

9.2 New Action Items

| <i>Item #</i> | <i>Assigned to</i> | <i>Details</i> |
|---------------|--------------------|----------------------------------------------------------------------------------------------------------------------------------------------------------------------|
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10 Next Meeting and Adjournment

The next meeting of the Japan TC Chapter of Automation Technology Global Technical Committee is scheduled for 13:30-15:30 April 22, 2016 at SEMI Japan office in Tokyo.



Respectfully submitted by:
Junko Collins
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SEMI Japan
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Email: jcollins@semi.org

Minutes approved by:

| | |
|------------------------------------------------------|--|
| <Makoto Ishikawa> (Nisshinbo Mechatronics), Co-chair | |
| <Terry Asakawa> (Tokyo Electron), Co-chair | |
| <Teruaki Ito>(Mitsubishi Electric), Co-chair | |

Table 8 Index of Available Attachments #1

| <i>Title</i> | <i>Title</i> |
|-----------------------------------------|--------------------------------------------|
| Required_Elements_Reg_20150327_E+J | SEMI Staff Report 2015.09.30_AT |
| 150604_All-Committee_Document-List (AT) | 150623_Japan_All-Committee-SNARF_List (AT) |
| | |

#1 Due to file size and delivery issues, attachments must be downloaded separately. A .zip file containing all attachments for these minutes is available at www.semi.org. For additional information or to obtain individual attachments, please contact Junko Collins at the contact information above.